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**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant: Shin-Hsin Chang : Group  
Serial No: 10/623,550 : Art Unit #1732  
Filed: 22 July 2003 : Examiner:  
Title: MANUFACTURING METHOD FOR : D.T. Beck  
POLYMER CHIPS CONTAINING  
METAL OR METAL OXIDE :  
NANOPARTICLES COMPONENT

**AMENDMENT**

Honorable Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

The Examiner issued an Office Action dated 28 June 2005 in the above-referenced Patent Application. The reply period having now expired, a Request and fee for a one (1) month Extension of Time is concurrently filed herewith to ensure timely filing.

Responsive to the outstanding Official Action dated 28 June 2005, please amend the above-referenced Patent Application as follows:

**Amendments to the Specification** begin on page 3 of this paper.

**Amendments to the Claims** are reflected in the Listing of Claims which begins on page 21 of this paper.

**Remarks/Arguments** begin on page 22 of this paper.

An **Appendix** including a Substitute Specification and Abstract are attached following page 26 of this paper.